Supplementary Information

Plasmonic Hot Hole Generation by Interband Transition in Gold-Polyaniline

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Table S1. Device code and conditions of fabrication.

Device	Sputtering	Polymerization	Working	Aniline	Deposition	Thickness
Code	power (W)	power (W)	Pressure	flow	time	(nm)
			(Torr)	(sccm)	(min)	
PD1	35					418
PD2	55	10	5×10^{-2}	30	10	444
PD3	70					352

Figure S1. Wavelength dependent I-V characteristics of (a) PD1 (b) PD2 and (c) PD3 devices



Device	λ (nm)	P (mW/cm ²)	$\mathbf{R}_{\lambda}(\mathbf{A}/\mathbf{W})$	G
	365		0.0067	0.0127
	450		0.0262	0.0721
	520	_	0.0049	0.0118
PD1	645	_	0.0025	0.0045
	750		0.0023	0.0034
	850		0.0020	0.0028
	950	_	0.0019	0.0023
	365		0.0042	0.0143
	450		0.0142	0.0391
	520	_	0.0035	0.0083
PD2	645 2	0.0018	0.0035	
	750		0.000759	0.0011
	850		0.000743	0.00096
	950		0.000733	0.00095
	365		0.00510	0.0173
	450		0.01660	0.0457
	520		0.00270	0.0064
PD3	645	645	0.00053	0.0010
	750		0.00055	0.000803
	850		0.00051	0.000695
	950		0.00053	0.000653

Table S2. Typical response parameters of the devices

 $\lambda-wavelength, P-incident \ power \ density, R_{\lambda}-responsivity, G-photoconductive \ gain$

Figure S2. **a.** Responsivity vs. wavelength plot of PD1, PD2, and PD3, **b.** External quantum efficacy (EQE) and internal quantum efficacy (IQE) of PD1 under illumination of blue light of intensity 2 mW/cm², **c.** variation of carriers collected per incident photon **d.** variation of carriers collected per absorbed photon.



Experimental method

A stainless steel cylindrical plasma reactor of 40 cm in length and 30 cm in diameter is used in this work. The plasma reactor is equipped with a water cooled planner RF electrode of diameter 10 cm and a planner magnetron of diameter 2.54 cm fitted with a high purity (99.99%) gold target, maintaining separation of 10 cm¹⁻³. The reactor is mechanically etched using fine polishing papers, chemically etched using acetone and then plasma etching is done at RF power of 100 W at a reactor pressure of 2×10^{-2} Torr in the presence of oxygen (10 sccm) and argon (30 sccm) for 45 min to remove the contamination. Before the introduction of any gas, the reactor is evacuated to a base pressure of 2×10^{-5} Torr by using a turbo molecular pump in combination with a dry roughing pump. Using a mass flow controller 40 sccm of pure argon (99.99%) gas is inserted into the reactor. By applying 50% speed of the turbo pump, argon pressure of 2×10^{-3} Torr. The flow of aniline vapor is controlled and recorded by a vapor source mass flow controller (1150, MKS Instruments, USA). Total reactor pressure with Argon and Aniline vapor is maintained at 5×10^{-2} Torr.

The magnetron system is connected to a pulse DC generator (Pinnacle Plus, Advanced Energy, USA) and power is adjusted to 35 W, 55 W, and 70 W at frequency 100 KHz and duty cycle 55%. The electrode assembly is connected to an RF generator (RF VII, USA), operated at 13.56 MHz and power is adjusted to 10 W. Chilled water (10° C) is allowed to pass through the magnetron and electrode assembly and both the power supplies for magnetron and electrode are switched ON. The deposition is carried out for 10 minutes. During polymerization, the reactor pressure is monitored by a capacitance manometer (Baratron, MKS Instruments, USA).

Device fabrication process

In this work we have fabricated 3 photodetectors namely PD1, PD2, and PD3, where PAni-Au nanocomposite thin film is the active material. The PAni-Au nanocomposite thin film is fabricated by plasma polymerization and simultaneous magnetron sputtering process. During the synthesis of PAni-Au nanocomposite thin films, the power applied in the magnetron is varied keeping the RF power fixed as listed in Table S1. The active material is sandwiched between transparent ITO coated PET and thermally evaporated Aluminum layers. The device has a lateral area of ~ 9.42×10^{-5} cm².

Thin film Characterization

The UV-Visible absorption spectra of the PAni-Au nanocomposite thin film deposited on the quartz substrate is recorded in UV3101PC, Shimadzu, Japan. Surface morphology of the PAni-Au nanocomposite thin film is recorded using a field emission scanning electron microscope (FESEM, Σ IGMA, Zeiss, Germany). The energy dispersive X-ray (EDX) spectra of the PAni-Au nanocomposite thin film deposited over a low doped silicon substrate is recorded using an FESEM coupled EDX. TEM analysis is carried out by JEM CM200 transmission electron microscope. The crystalline phase of PAni-Au nanocomposite is analyzed by X-Ray Diffractometer (XRD) (D8 Advanced, Germany) using Cu K_a radiation. HOMO and LUMO levels of PAni are determined from cyclic voltammetry^{4,5}.

Electrical measurements

The I-V characteristic of the present photodetectors are measured by Keithley 6517B electrometer/ high resistance meter in dark and under illumination of 365 nm, **450 nm**, 520 nm, 645 nm, 850 nm, and 950 nm LED light of intensity 2 mW/cm². For transient photocurrent measurement, the 450 nm light is switched ON and OFF for several times by using function generator at 0 V fixed bias, and a corresponding change in current is recorded.

Device parameter calculation

The measure of performance of photodetectors relies on the following important parameters (i) photoconductive gain (G), (ii) spectral responsivity (R_{λ}), (iii) specific detectivity (D*), and (iv) response speed.

The photoconductive gain of the photodetector represents the sensitivity to the signal. G is defined as the increase in number of collected carrier at the electrodes per unit absorbed photon (having energy hv) and mathematically expressed as⁴;

$$G = \frac{\Delta I/q}{P/h\nu}$$

where, $\Delta I = I_{light} - I_{dark}$, q is the elementary charge and P is the incident light power.

Spectral responsivity (R_{λ}) is another important parameter that reflects the electrical output per optical input of a photodetector. R_{λ} is expressed as⁴:

$$\mathbf{R}_{\lambda} = \frac{I_p}{\mathbf{PS}}$$

Where, I_p is the photocurrent generated in the device, P is the incident power of the light signal, and S is the effective area of the device.

The detectivity determines the minimum strength of signal that can be detectable above the noise level and is expressed by formula⁶:

$$\mathbf{D} = \frac{A^{1/2} R_{\lambda}}{(2\mathbf{q}I_{dark})^{1/2}}$$

where, I_{dark} is the dark current density, q is the charge of the electron.

Figure S3. XRD pattern of PAni-Au nanocomposite.





Figure S4. FESEM image of the PAni-Au nanocomposite film for (a) PD1, (b) PD2, and (c) PD3.

Figure S5. EDX spectrum and mapping of PAni-Au nanocomposite.





Figure S6. TEM morphologies of PAni-Au nanocomposite for (a) PD1 (b) PD2 and (c) PD3. The inset shows corresponding the SAED pattern.



References

1. Barman, T., Pal, A. R. & Chutia, J. Comparative Study of Structural and Optical Properties of Pulsed and RF Plasma Polymerized Aniline Films. *Appl. Surf. Sci.* **313**, 286–292 (2014).

2. Agarwala, M. *et al.* Highly Effective Antibiofilm Coating of Silver–Polymer Nanocomposite on Polymeric Medical Devices Deposited by one Step Plasma Process *J. Biomed. Mater. Res., Part B* **102**, 1223-1235 (2014).

3. Gogoi, D. *et al.* Immobilization of Trypsin on Plasma Prepared Ag/PPAni Nanocomposite Film for Efficient Digestion of Protein. *Mater. Sci. Eng.*, *C* **43**, 237–242 (2014).

4. Hussain, A. A., Pal, A. R. & Patil, D. S. High photosensitivity with enhanced photoelectrical contribution in hybrid nanocomposite flexible UV photodetector, *Org. Electron.* **15**, 2107–2115 (2014).

5. Hussain, A. A., Pal, A. R. & Patil, D. S. An efficient fast response and high-gain solar-blind flexible ultraviolet photodetector employing hybrid geometry, *Appl. Phys. Lett.* **104**, 193301 (2014)

6. Hong, Q. *et al.* Self-Powered Ultrafast Broadband Photodetector Based on p–n Heterojunctions of CuO/Si Nanowire Array, *ACS Appl. Mater. Interfaces* **6**, 20887–20894 (2014).